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501.41125X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. HIROI, et al  
Serial No.: 10/062,666  
Filed: February 5, 2002  
For: PATTERN INSPECTION METHOD AND SYSTEM THEREFOR  
Group: 2881  
Examiner: K. Fernandez

**RESPONSE AFTER FINAL ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 2, 2004

Sir:

In response to the Office Action dated January 2, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Claims;

Remarks are included following the amendments; and

A Notice of Appeal is included within this Amendment.

DC  
not  
encl  
7/22/04  
6/24/04